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LIST OF REFERENCES CALED BY APPEICANT				APPLICANT					
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)									
	Kazuo NAKAJIMA, et al., "Growth of Ge-rich, Six Ge <sub>1-x</sub> single crystal with uniform composition (x = 0.02) on a								
ADD	AW	compositionally graded crystal for use as GaAs solar cells*, JOURNAL OF CRYSTAL GROWTH, vol. 205, no. 3, August 1999, pages 270-276							
000	A V	Kazuo NAKAJIMA, et a	al., "Bridgman	growth of compositionally graded In <sub>x</sub> Ga <sub>1</sub>					
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	AZ					Additional References sheet(s) attached			
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*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									